501.32049RV1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Yujiro KAJIHARA & AL

Serial No.:

09/987,978

Filed:

16 November 2001

For:

LEAD FRAME SEMICONDUCTOR, INTEGRATED

CIRCUIT DEVICE USING THE SAME, AND METHOD OF AND PROCESS FOR FABRICATING THE TWO

Group:

Unassigned (Parent - 2815)

Examiner:

Unassigned (Parent - J. Clark)

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

21 February 2002

Sir:

In the matter of the above-identified application, Applicant hereby submits the attached information for consideration by the Office under 37 C.F.R. §§1.97 and 1.98, as listed on the accompanying Form PTO-1449.

Applicant states that references listed on the attached Form PTO-1449 were first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Statement. Attached is a copy of a Korean Office Action citing the information. The date of the Korean Office Action, 21 November 2001, is noted in the upper left-hand corner and the lower middle of page 2-1, and the references are listed at the bottom of page 2-1.

No fee is required for the filing of this Statement because it is being submitted with the above-identified application filed concurrently herewith, as well as a statement of certification of filing within the three (3) month period following issuance

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of an Action in a corresponding foreign application. However, if any fees are actually proper for the filing of this paper, please charge same to ATS&K Deposit Account No. 01-2135 (as Order No. 501.32049RV1), and please credit any overpayment or excess fees thereto.

Respectfully submitted,

Paul J. Skwierawski

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ATTACHMENTS:

Korean Office Action of 11/21/01 Form PTO-1449 JP Publication No. 03-032048A with English Abstract JP Publication No. 02-094547A with English Abstract

U.S. PATENT DOCUMENTS

| U.S. FATENT DOCUMENTS | | | | | |
|-----------------------|---|--|-----------------|------|----------------|
| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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